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PATENT

Docket No. JCL A6211Date: 1-17-2001

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ASSISTANT COMMISSIONER FOR PATENTS

WASHINGTON, D.C. 20231

ATTENTION: APPLICATION BRANCH

Sir:

Transmitted herewith for filing is the patent application of

Inventors: Yun-Kuei Yang, Yi- Ming Chang

For: METHOD OF USING ION IMPLANTATION TO FORM OPENINGS IN AN
INSULATOR

Enclosed are:

- Specification 14 pages.
- 6 Sheets of drawings
- Recordation Form Cover sheet with 2 pages assignment.
- A certified copy of Taiwan Patent Application No. dated
- SIGNED** declaration and power of attorney.
- Return Prepaid postcard.

CLAIMS AS FILED

FOR	NUMBER FILED	NUMBER EXTRA	RATE	FEES
Basic Fee			\$710.00	\$710.00
Total Claims	19	— 20 = 0	× \$18.00	\$0.00
Independent Claims	2	— 3 = 0	× \$80.00	\$0.00
If application contains any multiple dependent claim (s), then add				
TOTAL FILING FEE				<u>\$710.00</u>

- A check in the amount of \$710 cover the filing fee is enclosed.
- A check in the amount of \$40.00 to cover the assignment recording fee.
- A duplicate copy of this sheet is enclosed.

Jiawei Huang

Registration No. 43,330